

Gas Laser Technology for Future Laser Synchrotron Sources

**17th Advanced Beam Dynamics Workshop on
FUTURE LIGHT SOURCES**

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Igor Pogorelsky

S C O P E

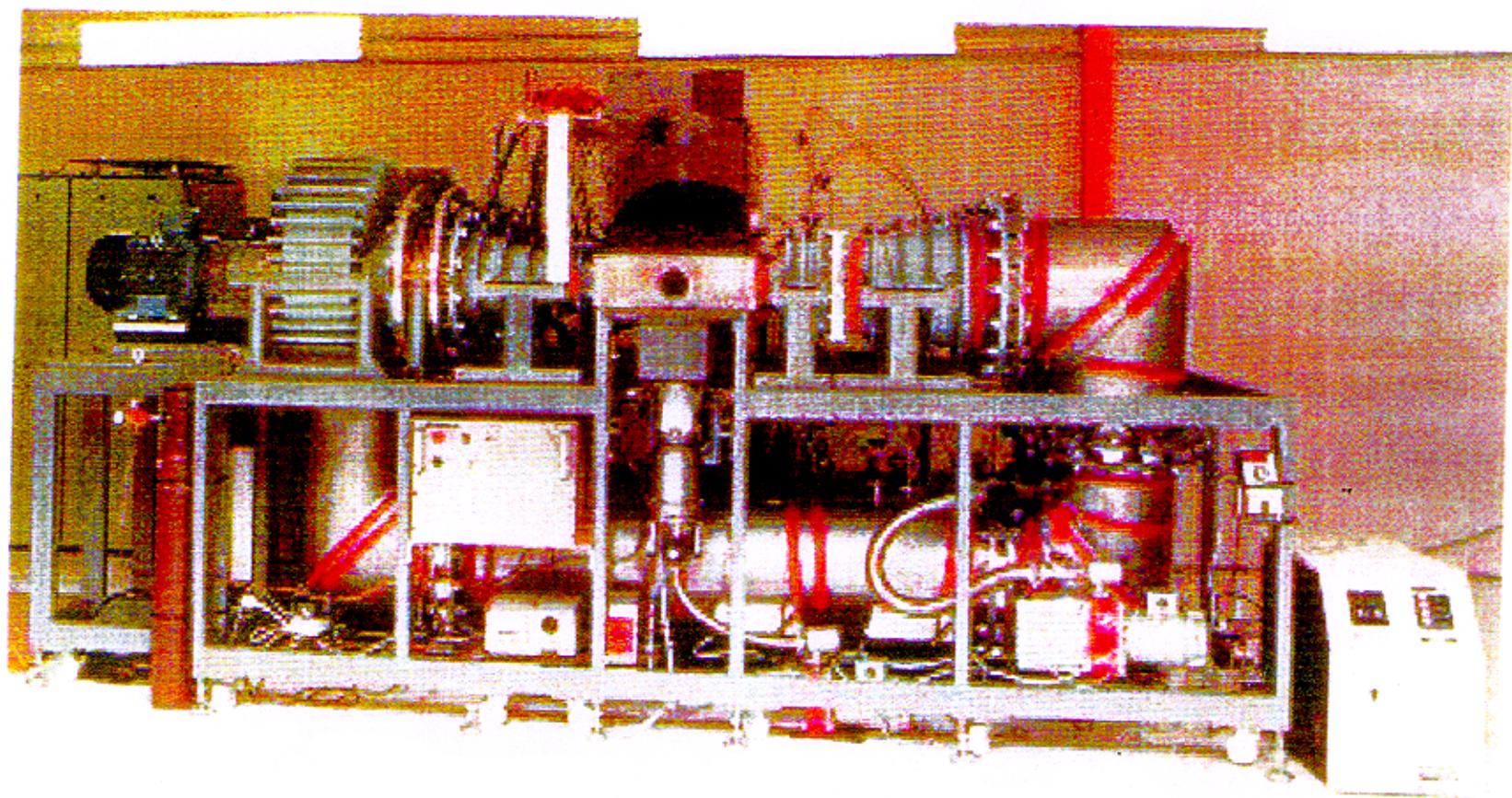
- ◇ LSS and laser accelerators will require pulsed, high peak power lasers operating at a high repetition rate compatible with the electron accelerator (around kHz)
- ◇ High yield requirements call for average power of the order of kW.
- ◇ The interacting electron and laser beams need to be tightly focused. The short Rayleigh length limits the duration of the laser pulse to a few picoseconds or less. Same for laser accelerators.
- ◇ Nanosecond laser pulses may be also useful
 - ◇ There are possibilities to transfer nano-pulses into pico-pulses.
 - ◇ For LSS we can confine the electron-laser interaction within a channel. Advantages over free space interaction: (a) avoid harmonics, (b) x-ray bandwidth is no more limited by the number of laser wavelengths within the pulse, (c) easy time synchronization.
- ◇ We search for gas lasers of pico-and nano-second pulse duration with a repetition rate in the kHz range and average power in the kW range

O U T L I N E

- ◇ Review of the high repetition rate high average power gas laser technology including: molecular, excimer, and chemical lasers
- ◇ Gas lasers capability to short pulse and high peak power
- ◇ Choice of CO₂ laser based on technical efficiency and ponderomotive effect
- ◇ TW ps regime for CO₂ lasers, example - ATF laser
- ◇ Examples of TW ps CO₂ laser application:
 - ◇ laser synchrotron source
 - ◇ laser wake field accelerator
- ◇ Technical approaches to TW ps CO₂ lasers of several kW average power and high repetition rate

VEL - "Very Large Excimer Laser"

100 Hz, 1 kW, 10 J/pulse, 10 ns

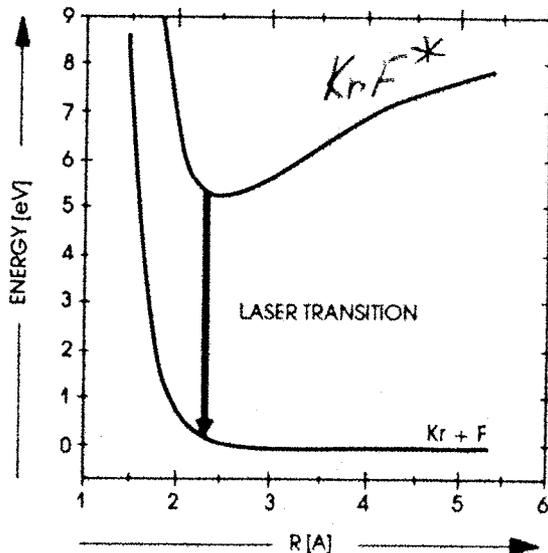
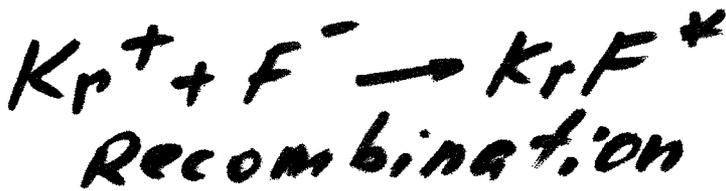
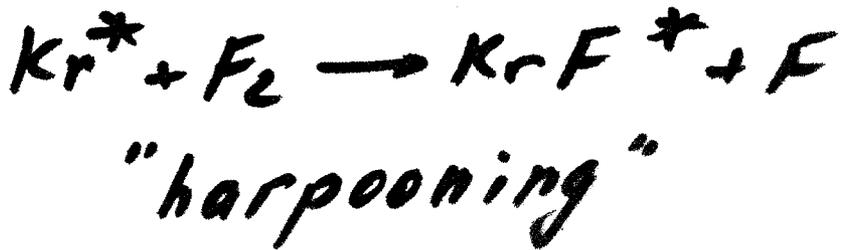


Gas lasers capable to high repetition rate in nanosecond pulse regime

	KrF, ArF, XeCl excimer discharge	Iodine photo- chemical	HF chemical	CO ₂ (CO) discharge
Wavelength [μm]	0.2-0.3	1.3	3-4	9-10 (4-5)
Average Power [kW]	1	10	1	50
Pulse Repetition Rate [kHz]	0.1-10	10	0.1	1
Wall-Plug Efficiency [%]	2	>100	180	30
Min. Pulse (theory) [ps]	0.15	1000	100	0.15

KrF Laser

e^-



bandwidth
 5nm or 20THz

Figure 1. Simplified potential transition curves for the KrF laser.

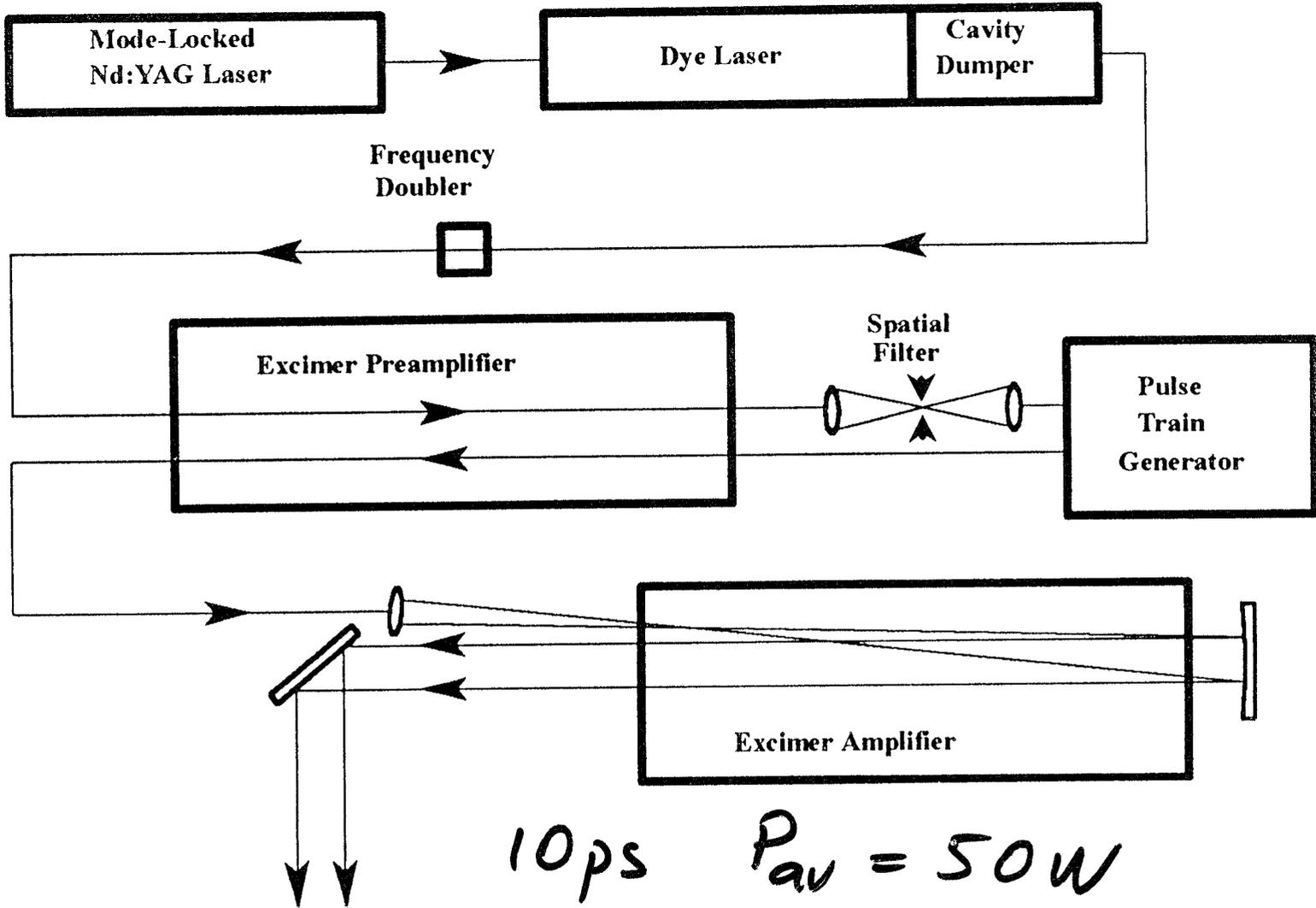


Figure 1. Laser System Schematic

$$20 \frac{\text{pulses}}{\text{train}} \times 400 \text{ Hz} = 8 \text{ kHz}$$

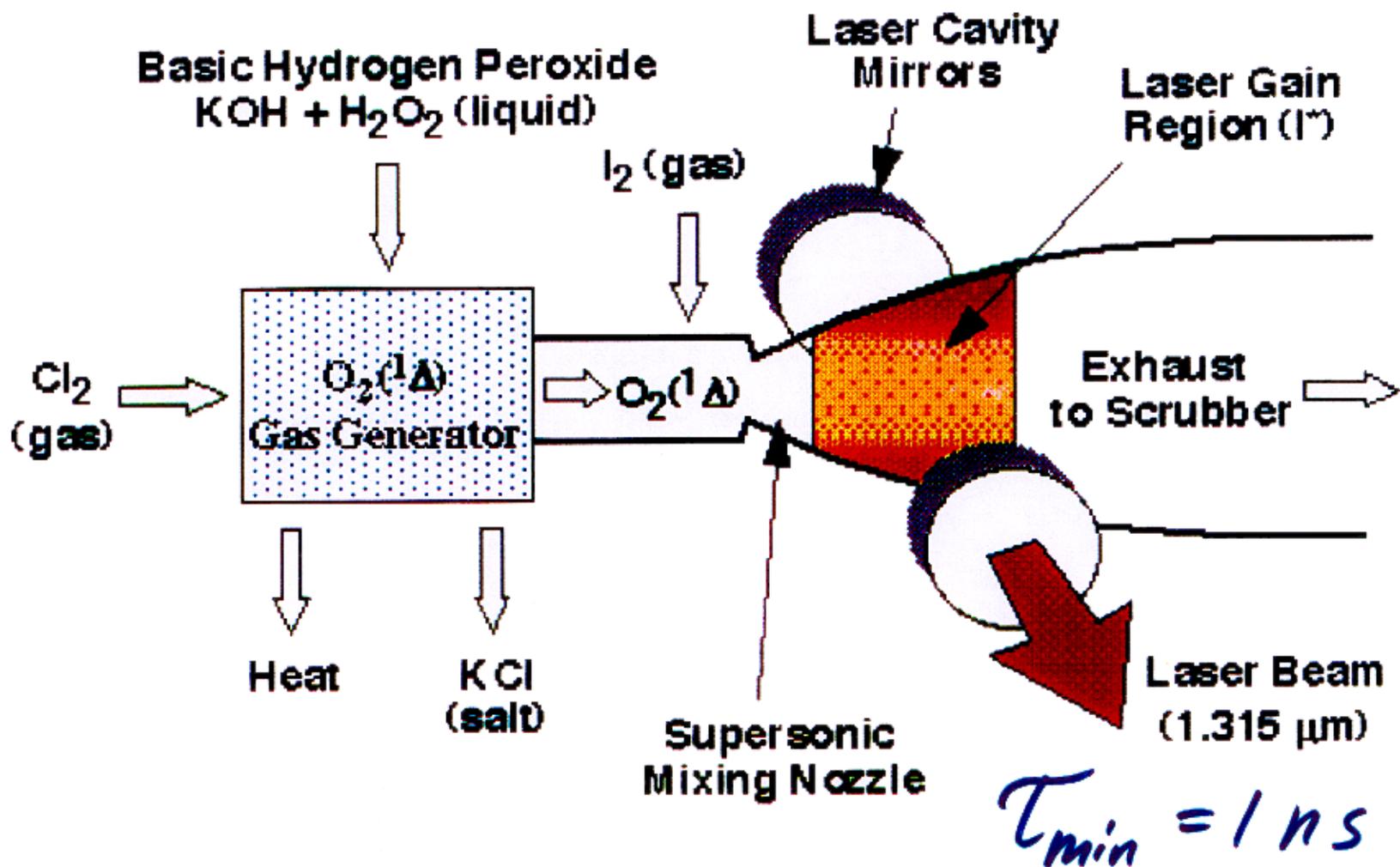
AIRBORNE LASER
system



Chemical iodite laser ($1.35 \mu\text{m}$)
1 kHz 10 kW



COIL - Chemical Oxygen Iodine Laser



Mobile 50 kW 100 Hz Russian CO₂ Laser

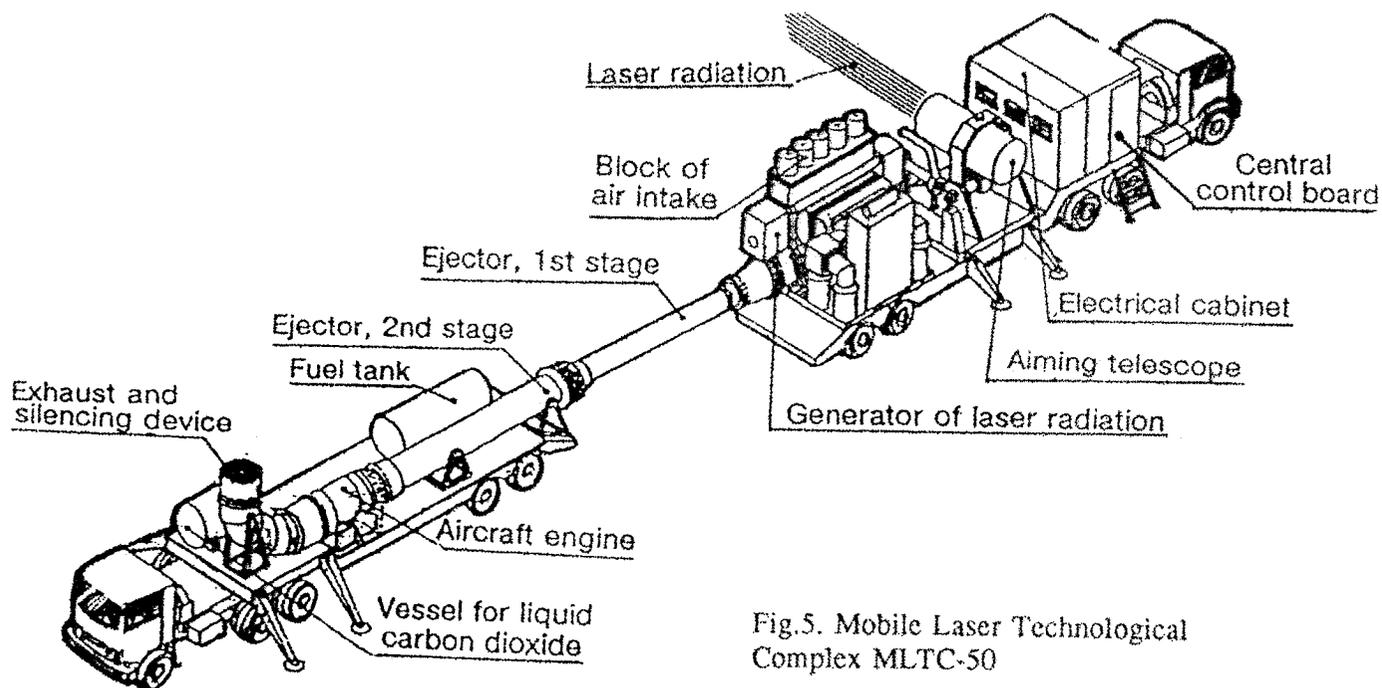


Fig.5. Mobile Laser Technological Complex MLTC-50

Type of system	HRR CO ₂ laser
Laser output	50 kW
Beam divergence	≤ 0,8 mrad
Work gas consumption	
atmospheric air	4,65 kg/sec
CO ₂ gas	0,35 kg/sec
Fuel outlay (kerosine TS-1)	45 kg/min
Continual work time during 1 run	1 + 10 min
Interval between runs	≤ 30 min
Tracking error	≤ 0,05 mrad
Focusing range	20 + 80 m
Mass	30 t
Transport means	
traction car MAZ-6422	2 piece
couple CM MAZ-93853	2 piece
Service personnel	3 persons
Power supply	≥ 600 kW
Cooling water consumption	250 l/min



For processes based on electron oscillation

(plasma wake generation or Compton scattering)

CO₂ laser permits:

- increase (100 times to compare with $\lambda=1 \mu\text{m}$) in the ponderomotive potential of electron oscillatory motion $\epsilon_p = e^2 E_L^2 / 2m \omega^2$

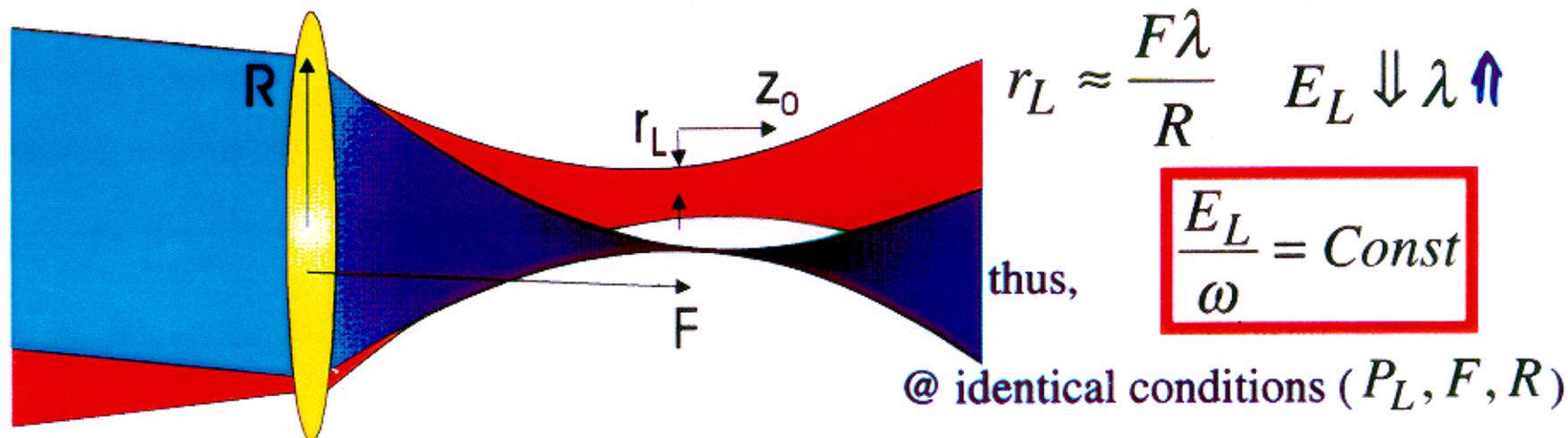
characteristic for: plasma wave excitation,
relativistic self-focusing,
gas ionization,
Compton scattering.

- increase (10 times to compare with $\lambda=1 \mu\text{m}$) in the dimensionless laser strength parameter $a = eE_L / mc \omega$

characteristic for: laser wakefield and beatwave accelerators,
harmonic generation.



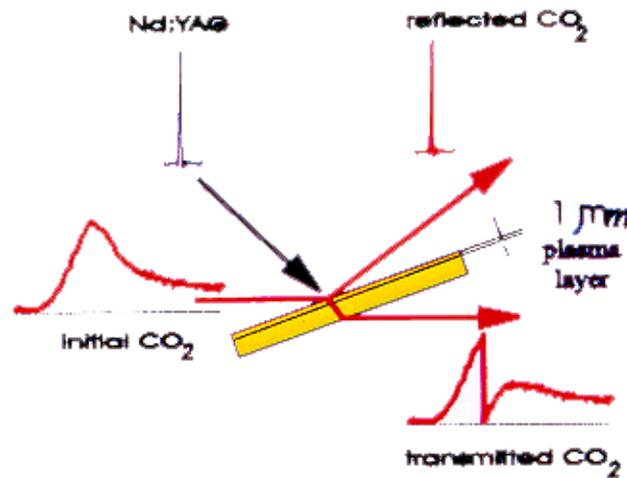
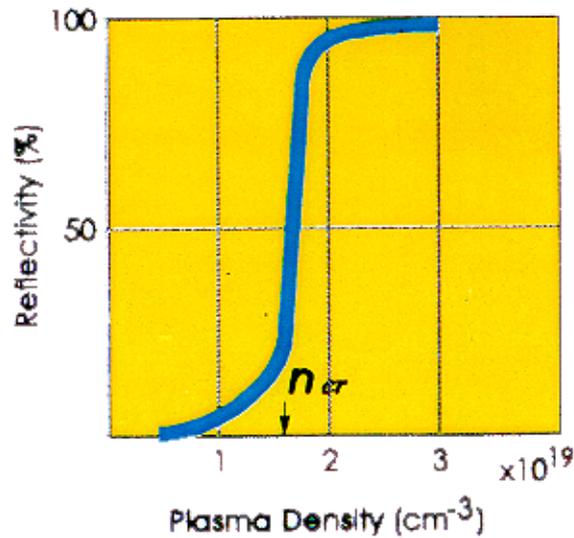
Short wavelength permits tighter focusing...



Note, that the high-field volume $V \propto z_0 r_L^2 \propto \lambda^3$

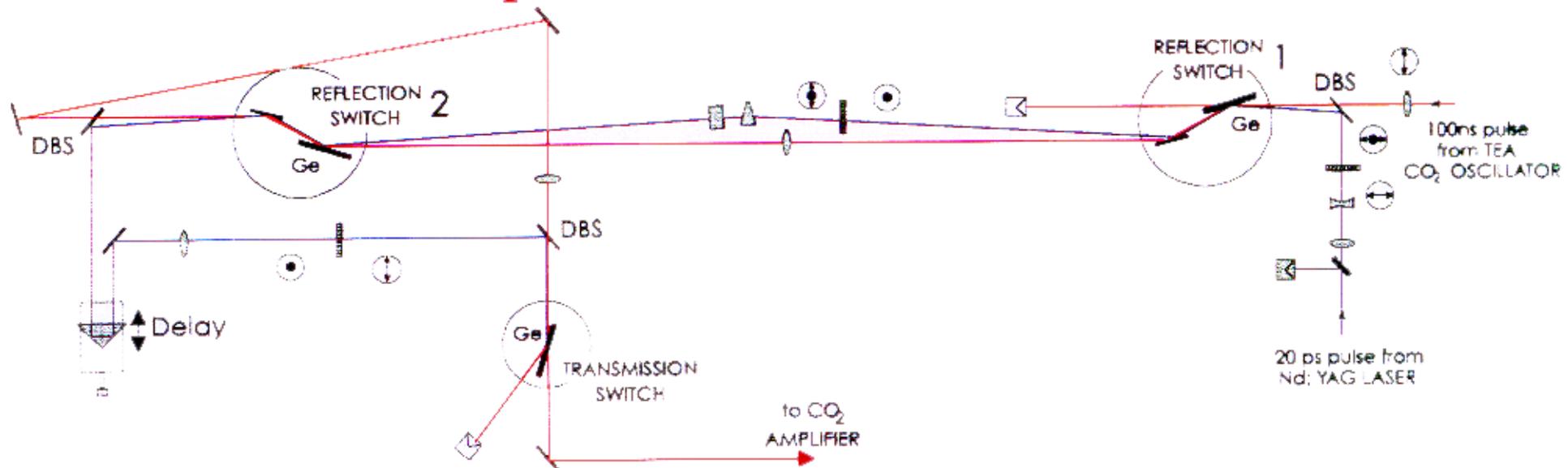
That may define the integral number of observed events

Semiconductor Optical Switching of CO₂ Laser Pulses



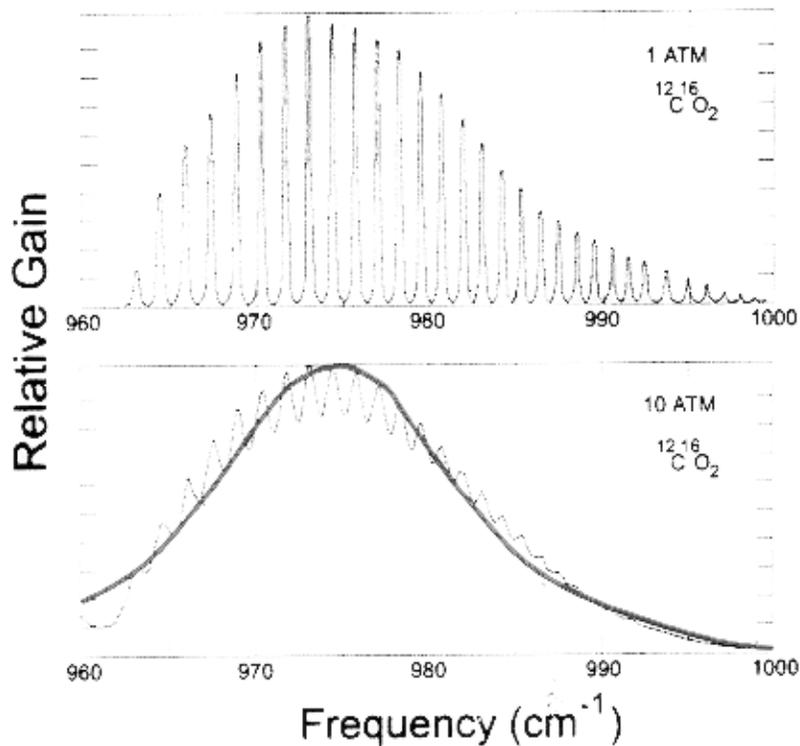
◆ Upon absorption of photons above the band gap energy, the semiconductor switches from transparent for $\lambda=10 \mu\text{m}$ window to metal-like mirror.

ATF picosecond pulse slicing system

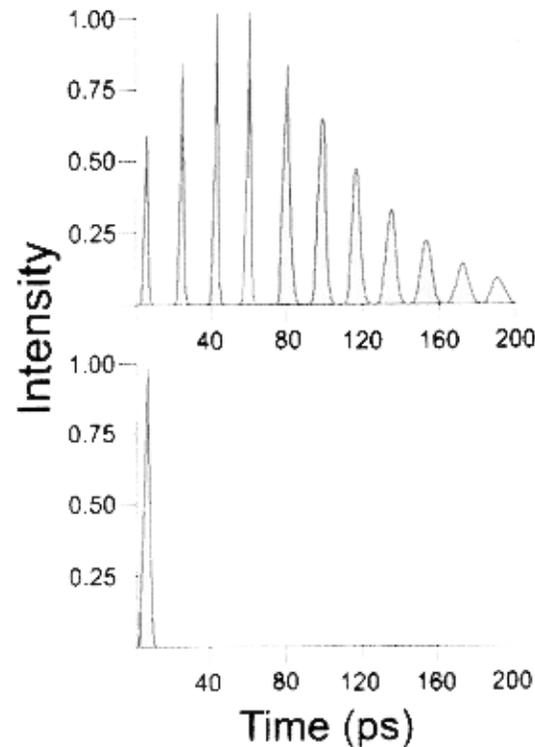


Bandwidth Limited Amplification of Picosecond CO₂ Laser Pulses

Gain Spectrum



Amplified Picosecond Pulse

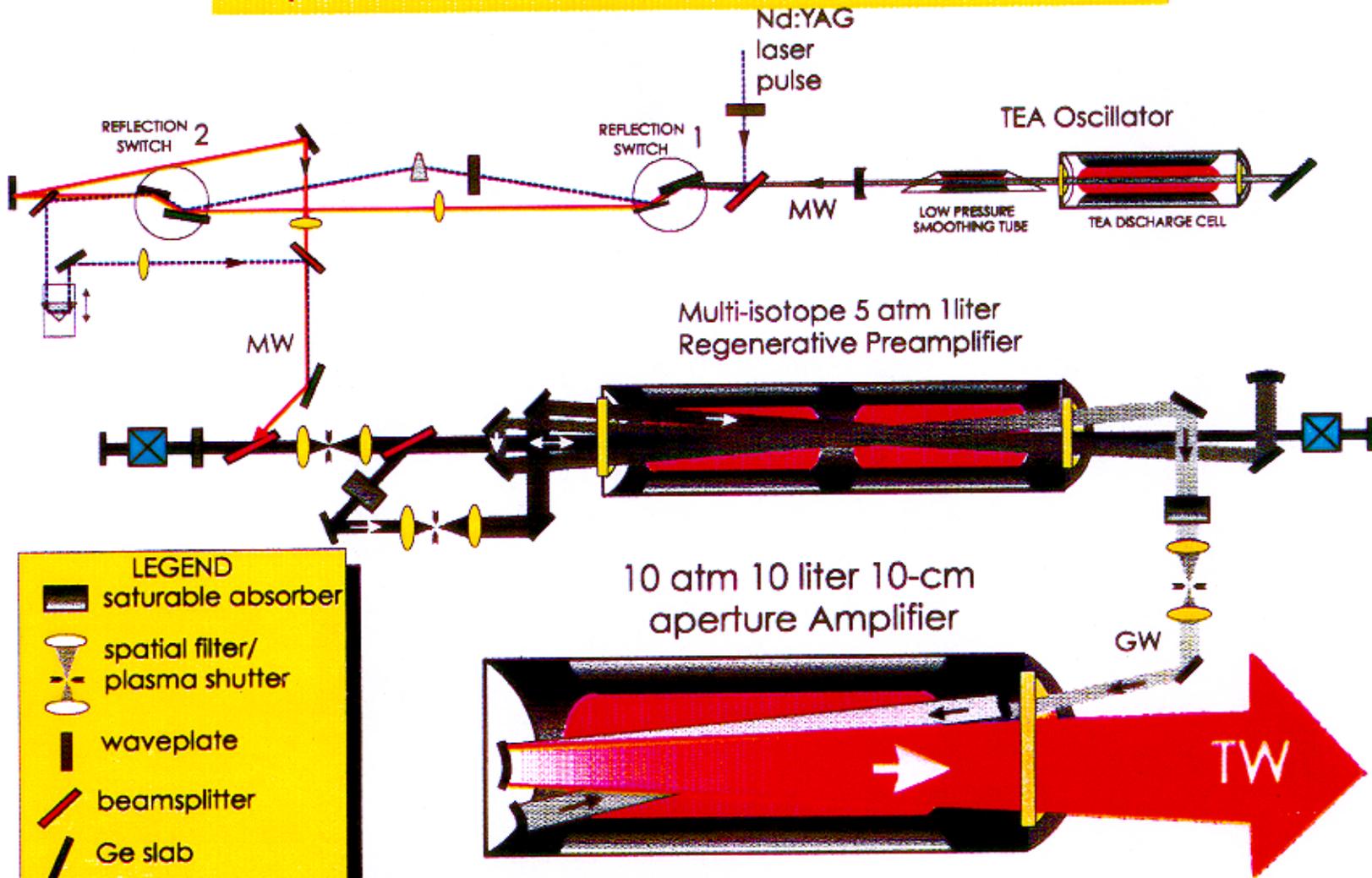


Strongly modulated rotational line structure of the CO₂ gain spectrum modifies the frequency content of picosecond pulses, changing their temporal structure.

At 10 atmospheres, collisional broadening produces overlap of the rotational lines into the 1 THz wide quasi-continuous gain spectrum, and pulses as short as 1 ps can be amplified without distortion.



Brookhaven National Laboratory Accelerator Test Facility

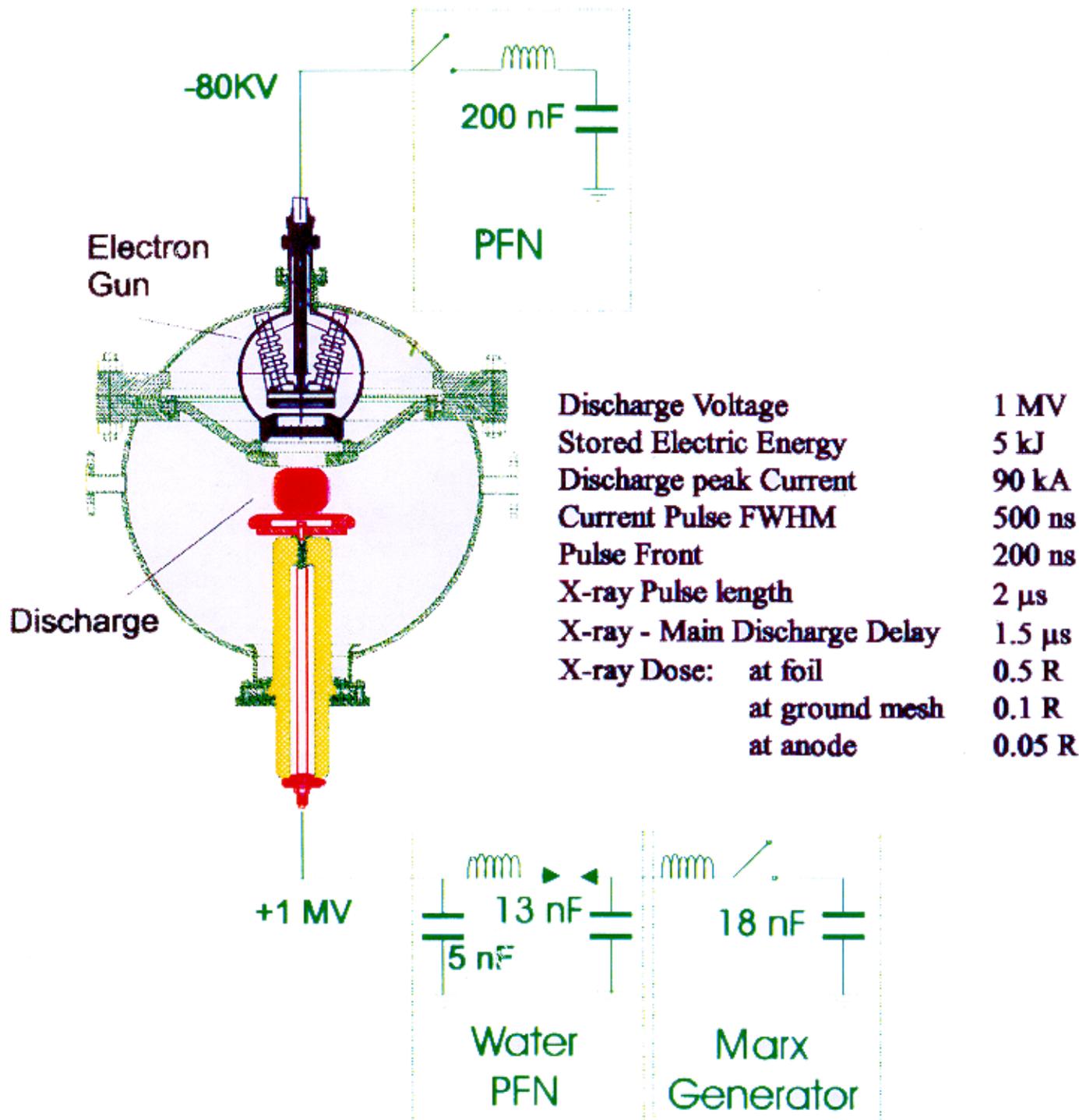


LEGEND

- saturable absorber
- spatial filter/
plasma shutter
- waveplate
- beamsplitter
- Ge slab
- Pockels cell

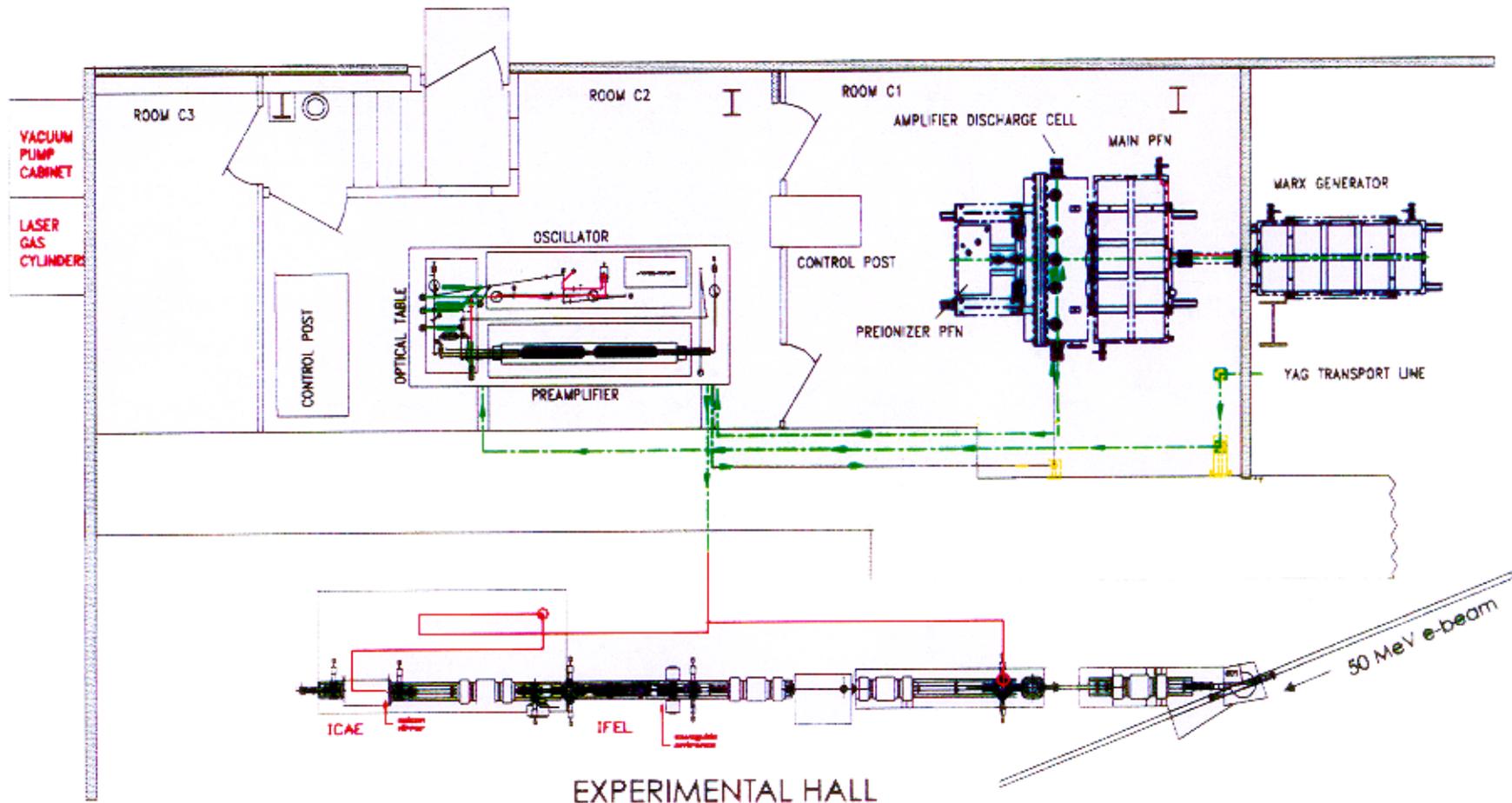


Amplifier Discharge Cell

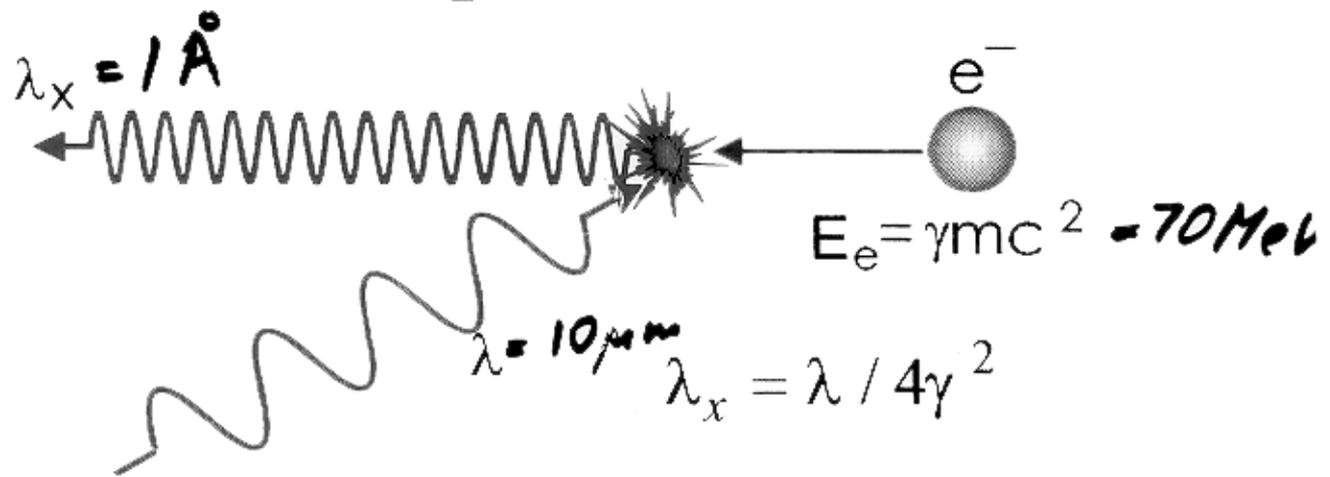




Floor plan of the BNL ATF shows experimental hall and CO₂ laser rooms



Laser Synchrotron Source with TWps-CO₂ Driver



Concept of LSS permits:

- ◆ easy access to x-ray and gamma regions with compact linac
- ◆ femtosecond x-ray pulses due to available technique of ultra-short electron bunches from photocathode guns

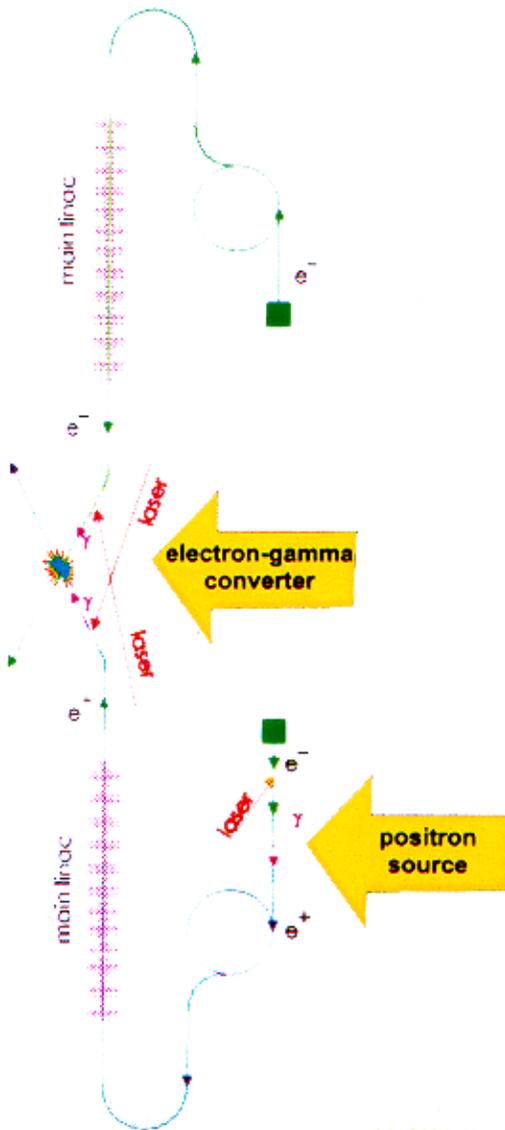
Choosing CO₂ laser instead of 1- μm laser requires 3 times in γ increase, then:

- ◆ Divergence $\theta \approx 1/\gamma$ drops 3 times
- ◆ Flux $P_x \propto \lambda E_L Q \gamma^2 / \tau_b r_b^2$ increases 10 times
- ◆ Brightness $B \propto P_x / (2\pi r \theta)^2$ increases 100 times

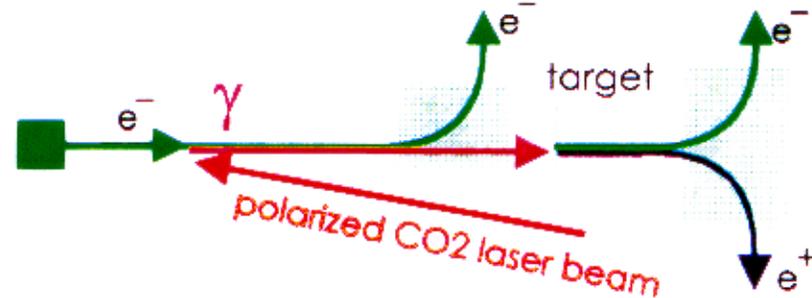
Electron \Rightarrow Gamma Converters for Future Linear Colliders

CO₂ laser for $e^- \Rightarrow \gamma$ converter at 2.5 TeV

- ◆ $\hbar\omega_\gamma = [x/(x+1)]E_e$, where $x = 4E_e\hbar\omega/m^2c^4$
For $E_e=2.5$ TeV and $\lambda=10$ μm , $x=4.8$ and $\hbar\omega_\gamma \approx E_e$
- ◆ Rescattering $\gamma+\lambda \Rightarrow e^-+e^+$ when $\omega\omega_\gamma > m^2c^4/\hbar^2$ or $\lambda[\mu\text{m}] < 4.2E_e[\text{TeV}]$.
For the $E_e=2.5$ TeV, $\lambda=10.5$ μm is the optimum choice.
- ◆ For $\tau_L=1$ ps, probability of the $e^\pm \Rightarrow \gamma$ conversion $\chi = \sigma_c E_L/\hbar\tau_Lc^2$ reaches unity at the laser pulse energy $E_L \approx 1$ J.
- ◆ Fast-flow TWps-CO₂ laser operating at 100 Hz repetition rate will amplify trains of a hundred 1 ps pulses spaced by 1 ns (aggregated pulse repetition rate 10 kHz) at wall-plug efficiency 10%.



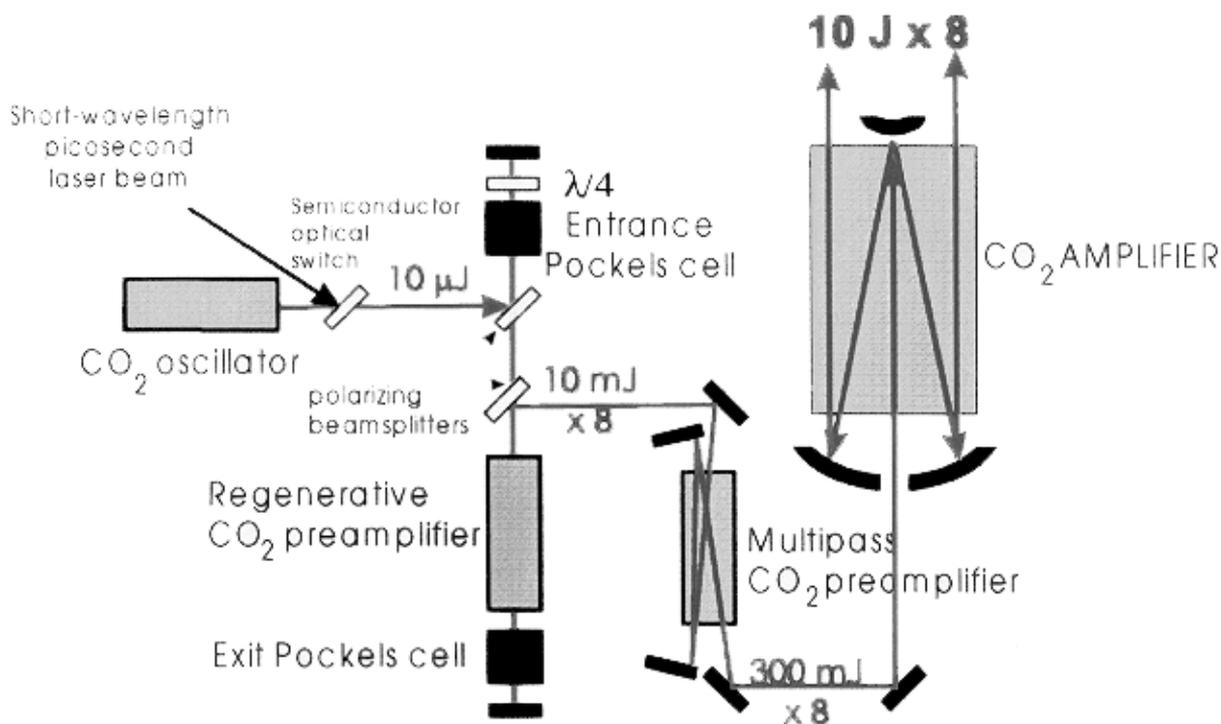
Polarized positron source for Japan Linear Collider



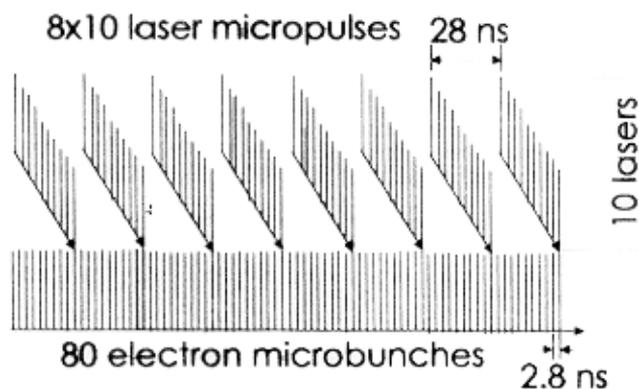
CO₂ laser produces 10 times more photons per joule than solid state laser

T. Hirose
TML

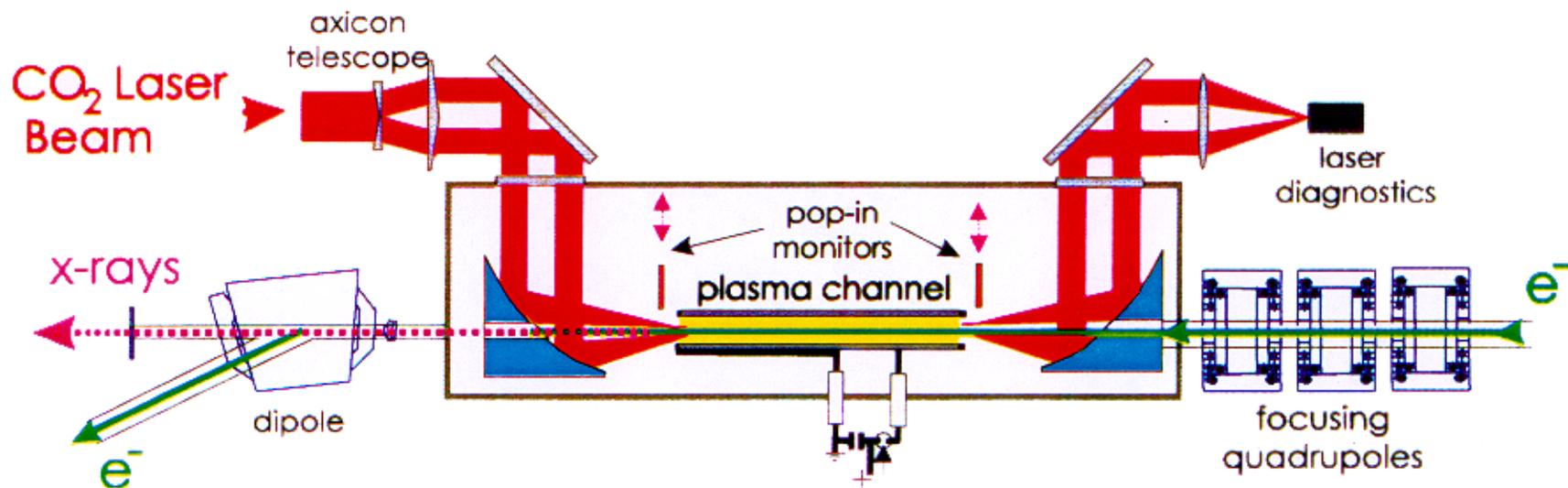
Pulse-Train Picosecond CO₂ Laser



Example of pulse train laser multiplexing to fit requirements of the JLC polarized positron source



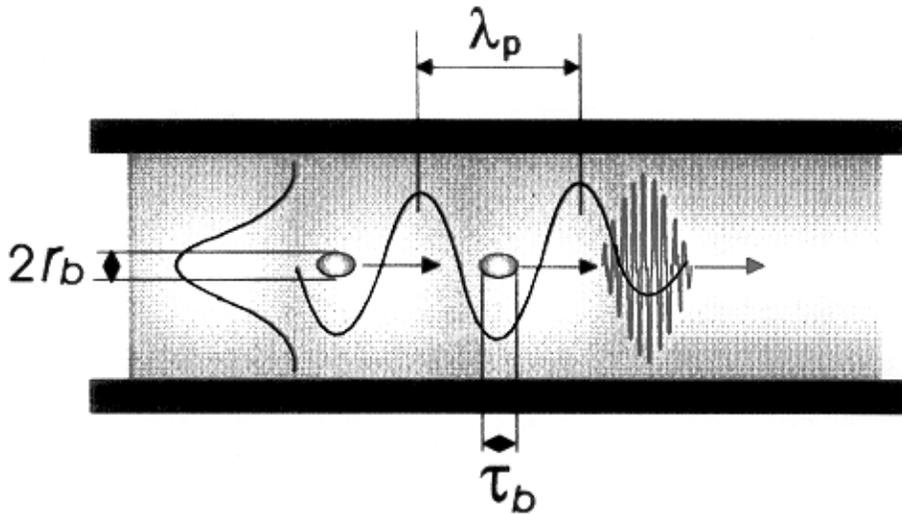
Prospective Compton Scattering Experiment in Plasma Channel





Approach to monochromatic LWFA

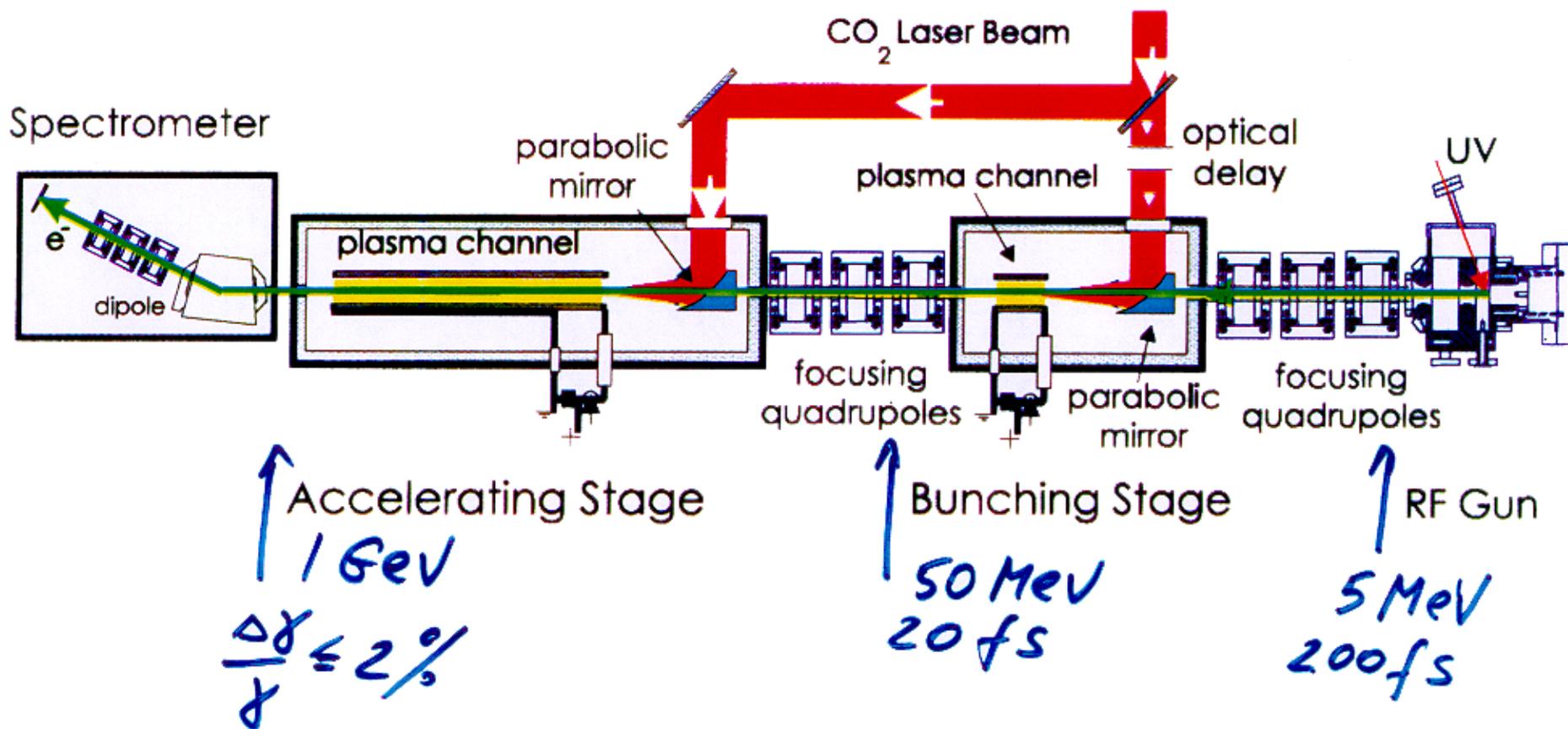
- **Linear regime of plasma wakefield generation ($a < 1$)**
- **Channeling of the laser beam**
- **Longitudinal and transverse sizes of the injected electron bunch have to be small to compare with λ_p**



- **Maximum bunch charge** $N_e^{\max} \propto \lambda_p$
- **The maximum amplitude of the accelerating plasma wakefield** $E_a^{\max} [\text{GV} / \text{m}] = 2.8 \times 10^4 \left(\frac{\lambda}{r_L} \right)^2 P_L [\text{TW}] / \lambda_p [\mu\text{m}]$
- **Combination of terawatt picosecond CO₂ laser with subpicosecond photocathode electron gun - opens the way to practical monochromatic laser accelerators**

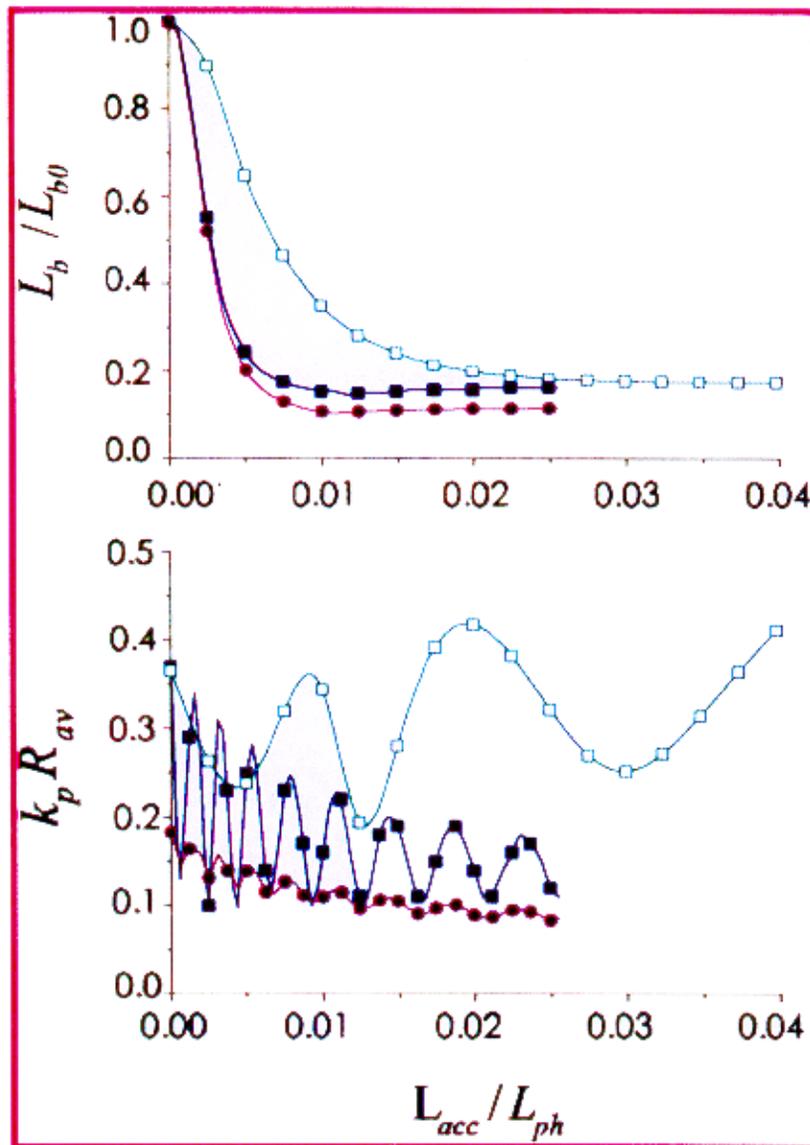


Principle diagram of the two-stage monochromatic LWFA





Bunch compression in channel guided LWFA



plasma parameters: $\lambda_p = 800 \mu\text{m}$, $k_p R_{ch} = 14.3$

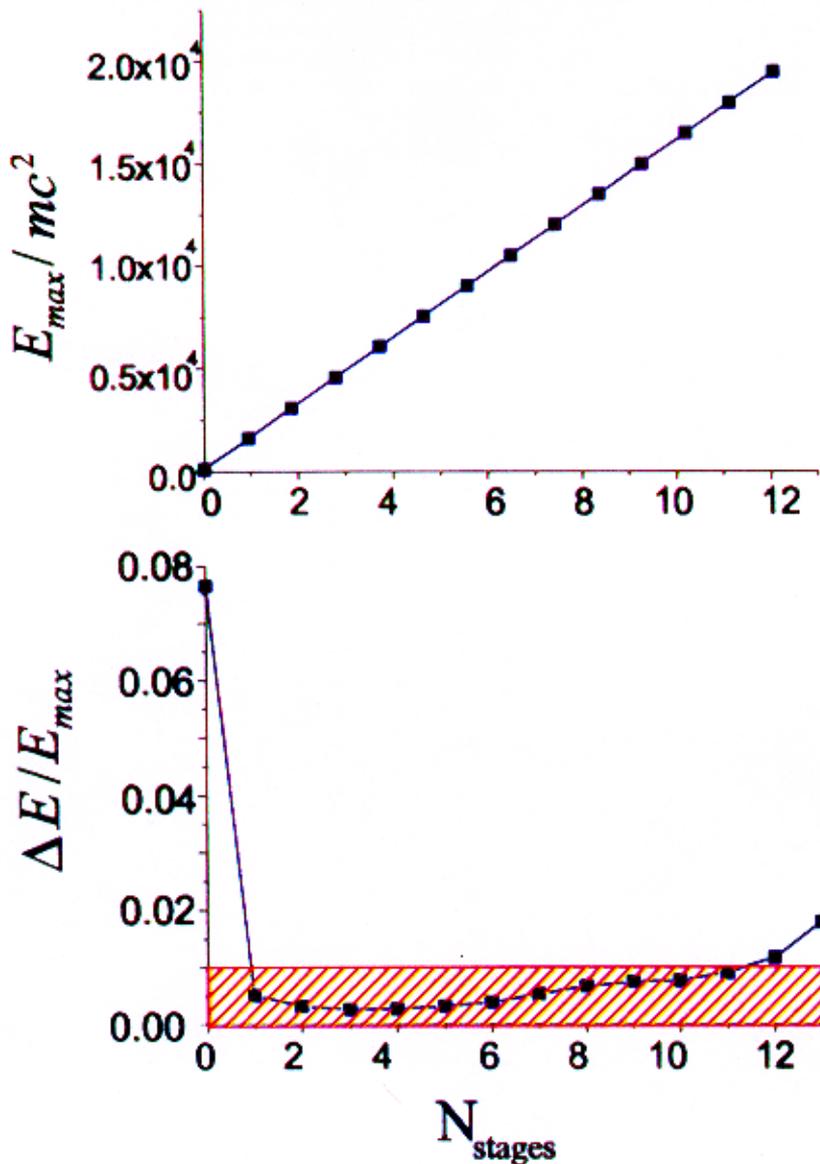
bunch parameters: $E_{inj} = 5 \text{ MeV}$, $\Delta E/E = 1.5\%$, $\epsilon = 0.6 \text{ mm.mrad}$,

$L_{b0} = 30 \mu\text{m}$ (100 fs), $r_{Lo} = 25$ or $50 \mu\text{m}$

wakefield amplitude: $\phi_{max} = 0.04$ or 0.19



Multi-stage monochromatic LWFA with prebuncher



CO₂ laser (per each stage): $P_L=50$ TW, $\tau_L=1$ ps, $a^2=0.5$

plasma parameters: $\lambda_p=800$ μm , $k_p R_{ch}=14.3$

bunch parameters (before bunching stage):

$\tau_{b0}=100$ fs; $r_{b0}=50$ μm , $\epsilon=0.6$ mm.mrad

Feasible high repetition rate regimes for picosecond CO₂ lasers

- ◇ **X-ray preionized high-pressure gas discharge controlled by semiconductor switches**
- ◇ **Chemical pumping via energy transfer from DF to CO₂**
- ◇ **Optical pumping or energy transfer from nanosecond CO₂ pulses to picosecond laser pulses**
 - ◇ **9 μm CO₂ laser pumping of 10 μm CO₂ transitions**
 - ◇ **CO₂ laser pumping of other molecular gases (NH₃)**
 - ◇ **Energy exchange between counter-propagating CO₂ laser pulses in plasma (G. Shvets)**

Short Pulse Amplification by Raman Scattering

- Three-wave interaction

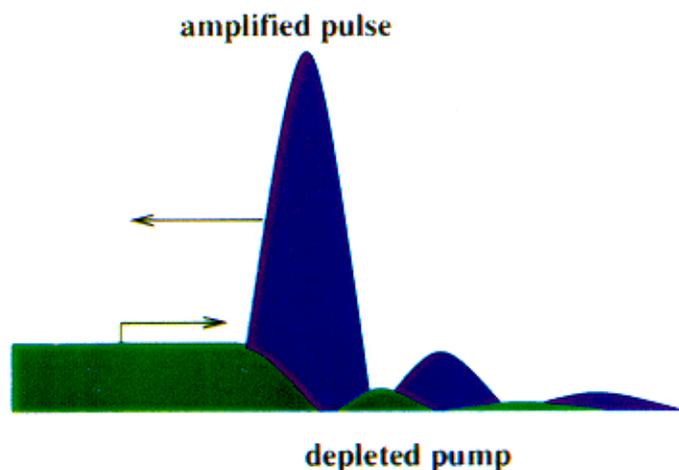
Pump a_1 , Signal a_0 , Plasma Wave $f = eE_z/mc\omega_p$

- Resonant excitation of Plasma Wave

Laser detuning $\Delta\omega = -\omega_p$

- Plasma Wave linear \Rightarrow no wavebreaking

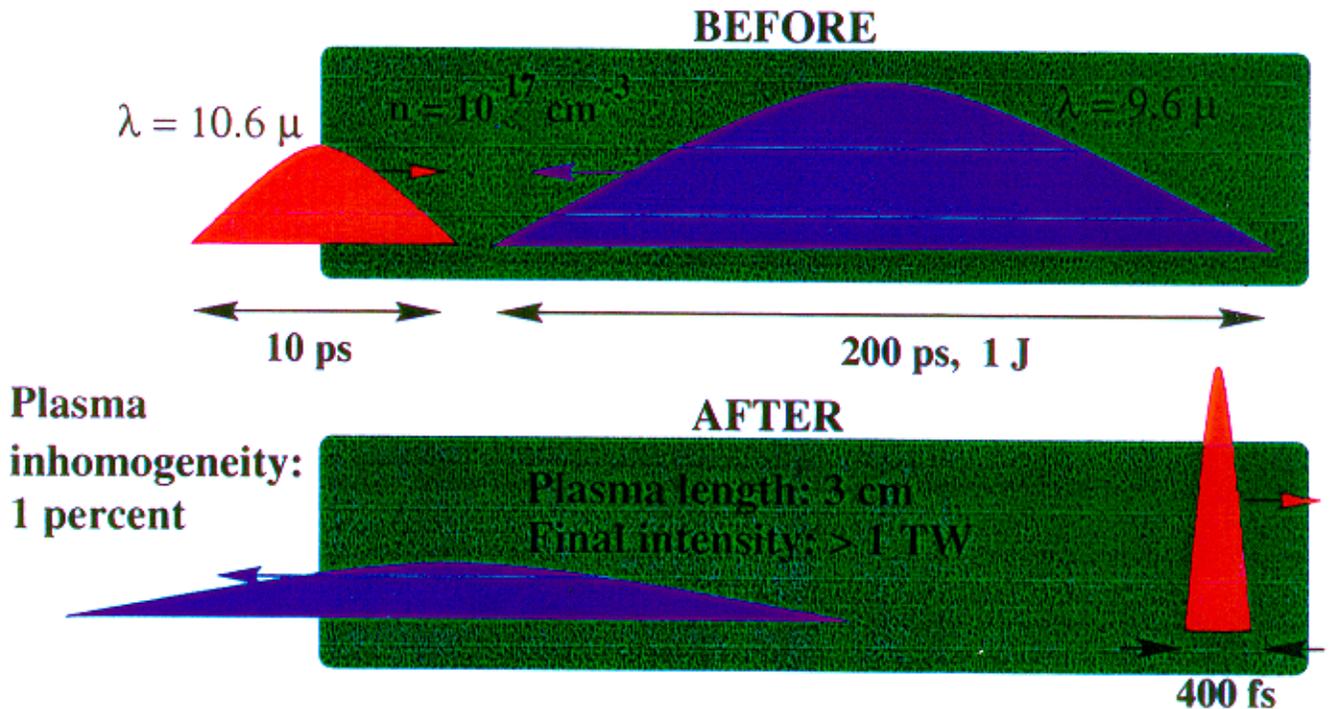
- Total Pump Depletion



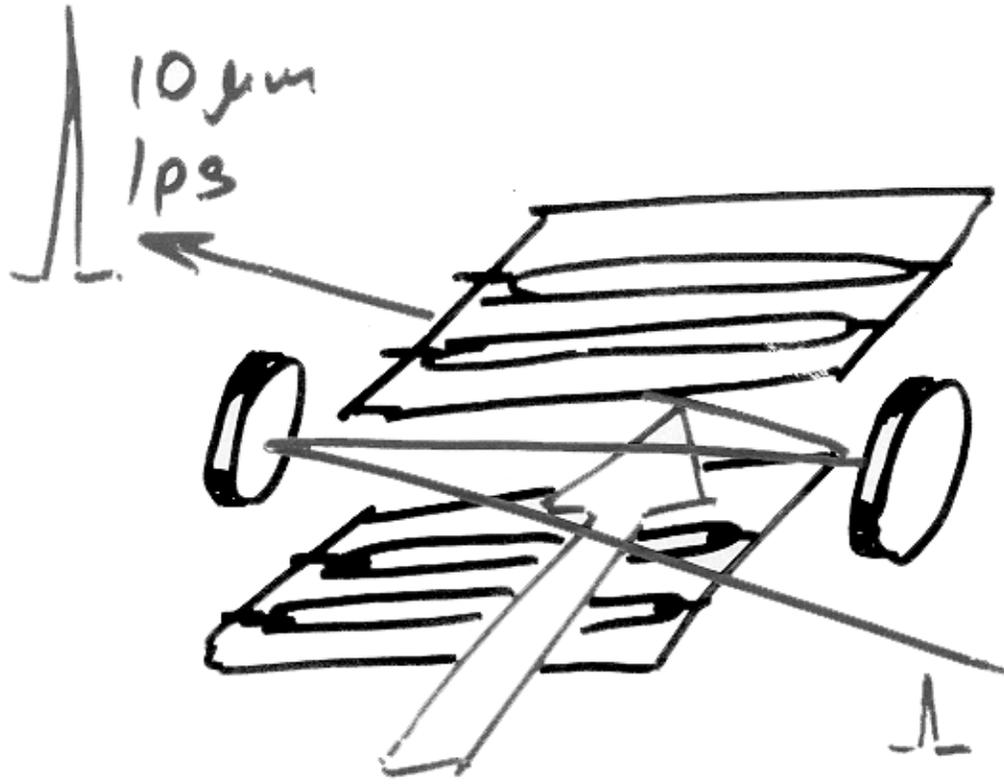
Further Compression of a Sliced Pulse by RBS

- Two-color amplifier which produces short pulse ω_0 and pump pulse $\omega_0 - \Delta\omega$
- Short-pulse duration $\tau_0 \gg (1/\Delta\omega)$
Long-pulse duration $\tau_p = 2L_{pl}/c$
- Plasma of resonant density $n = m\Delta\omega^2/4\pi e^2$

What can be done at ATF

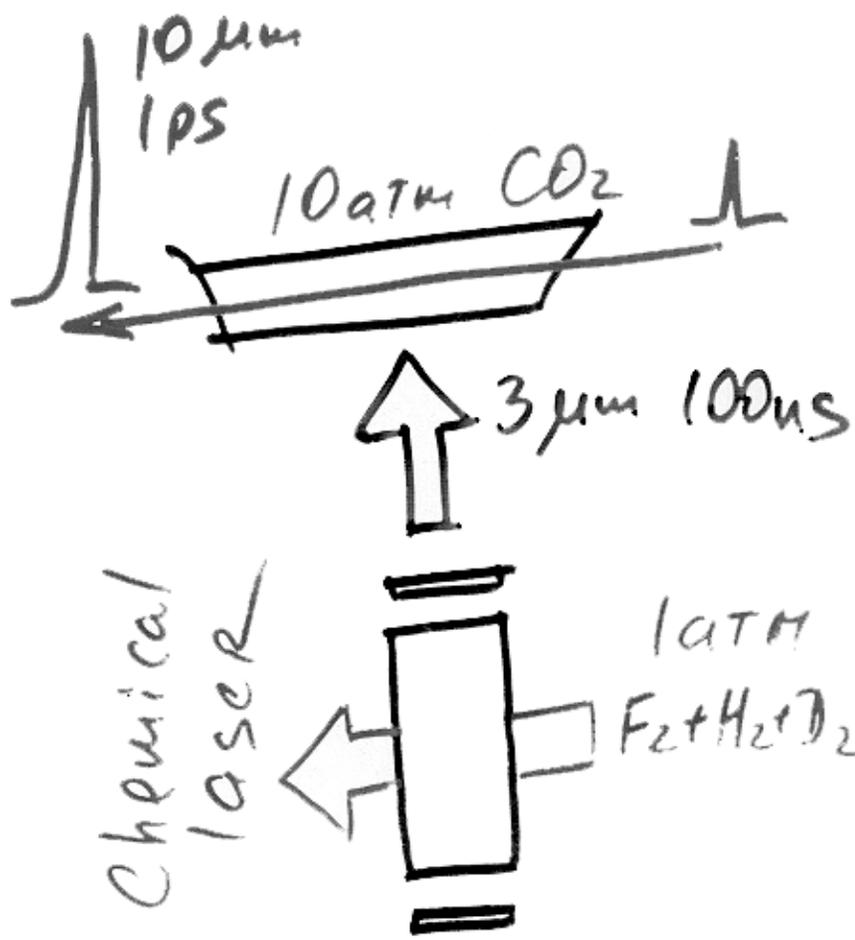


Compression via superradiant amplification impossible:
 $\tau_0 \gg \frac{1}{\omega_p}$. **Note:** In Raman regime seed pulse rapidly contracts $\propto z^{-1}$.



10 atm $F_2 + H_2 + D_2 + CO_2$
 $DF^* + CO_2 \rightarrow CO_2^*$

CO₂ laser with direct chemical pumping



CO₂ amplifier with optical pumping by chemical laser

Gas discharge pulsed power circuit with solid state switches

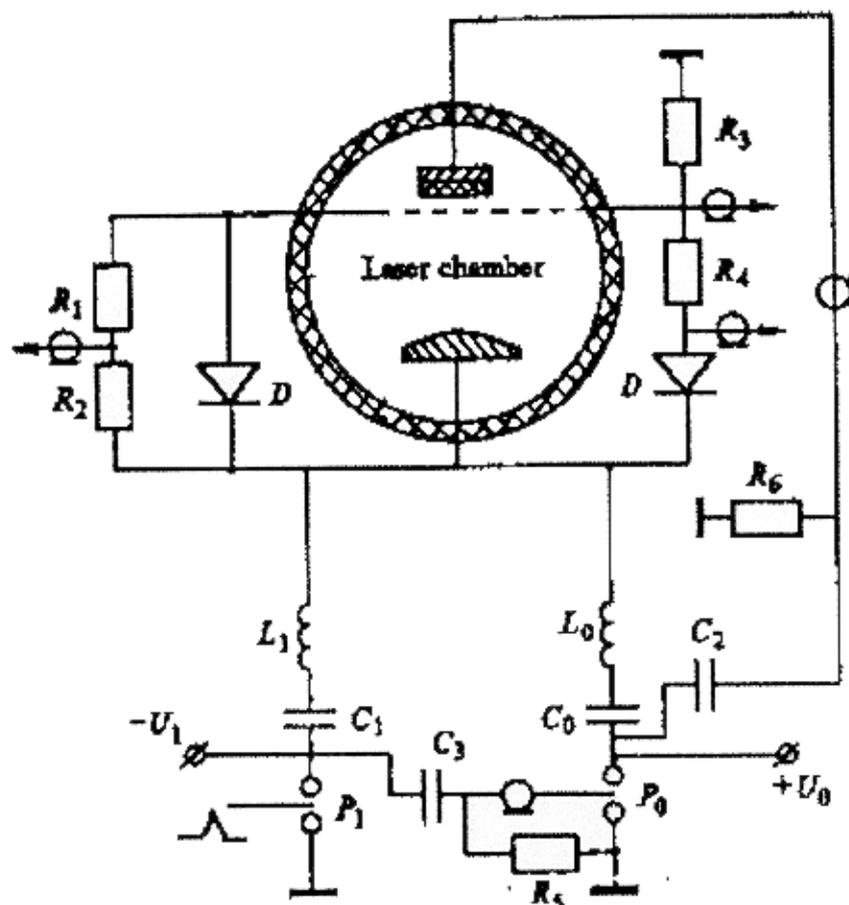


Fig. 1. Schematic of the transverse discharge laser. D : semiconductor diodes; P_0, P_1 : RU-65 spark gaps; C_0, C_1 : capacitance of the main and driving circuits, respectively; C_2 : preionization capacitor; C_3 : capacitor starting P_0 ; L_0, L_1 : the circuit inductors; $R_1 - R_6$: voltage divider, resistive shunts, and charging resistors, respectively.

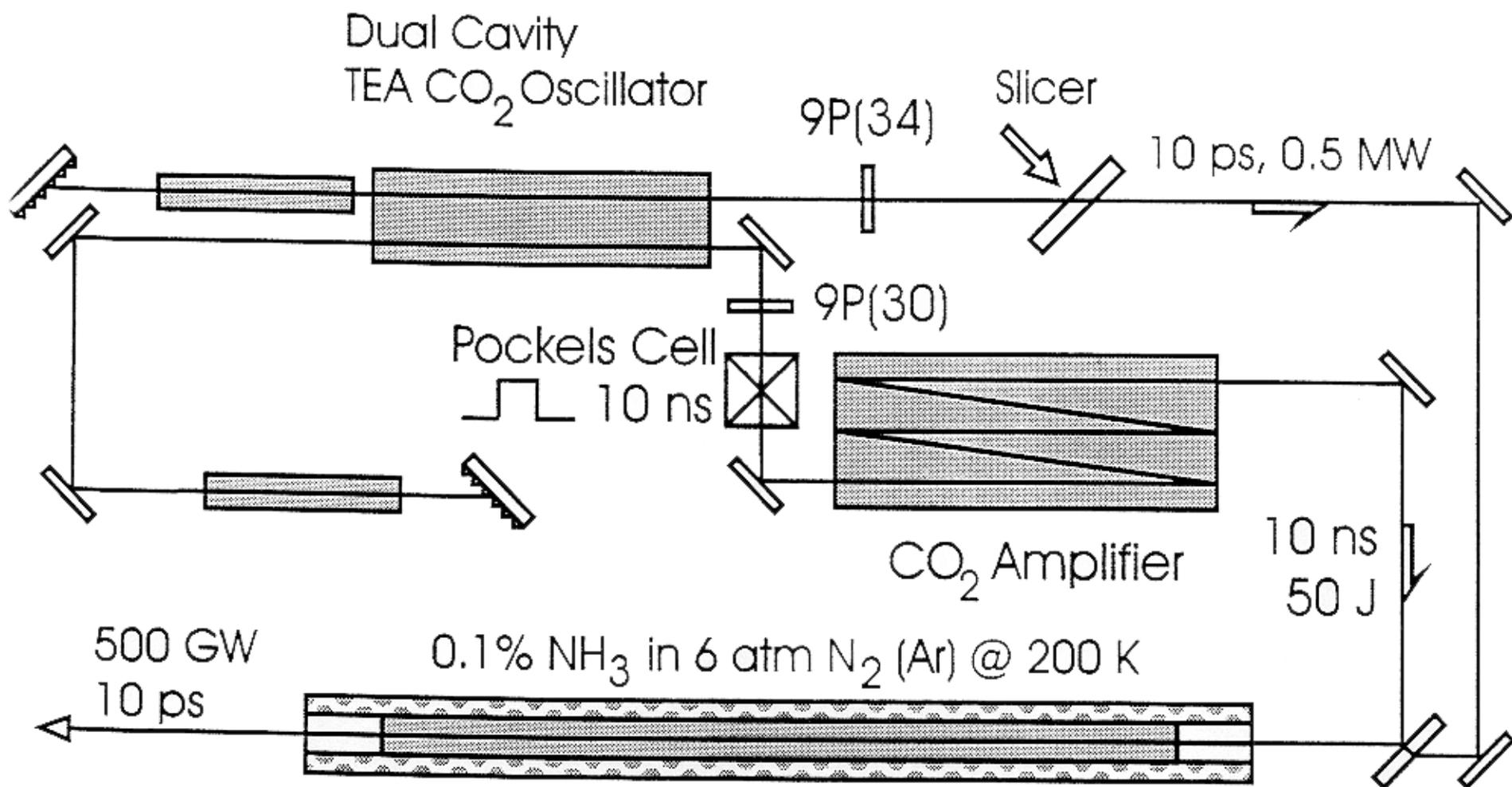
Semiconductor switches transmit current up to 8 kA and withstand the voltage up to 120 kV. They operate at 1 kHz and higher with switching time ~ 10 ns, can be placed in series and in parallel. Thus, for 500 kV and 100 kA we need about 60 switches.

Among other problems to solve:

high-speed gas circulation at 10 atm

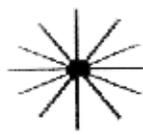
high-speed vacuum pumping of x-ray tube

NH₃ Amplifier



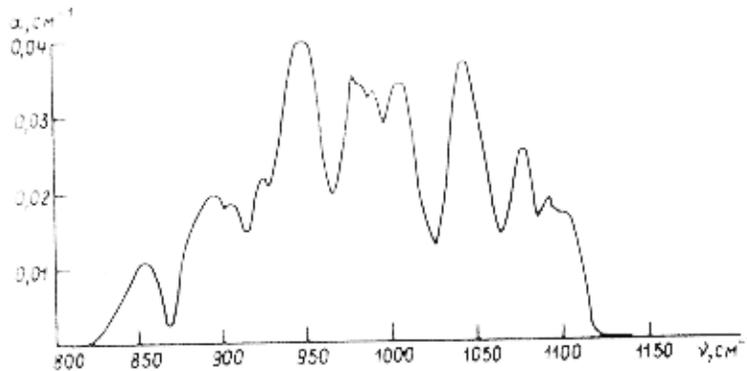
Predicted: 60 dB gain at 3 J/cm², 10 ns pump CO₂ pulse*

*[J.D. White and J. Reid, IEEE J. Quant. Electron., vol.29, 201 (1993)]



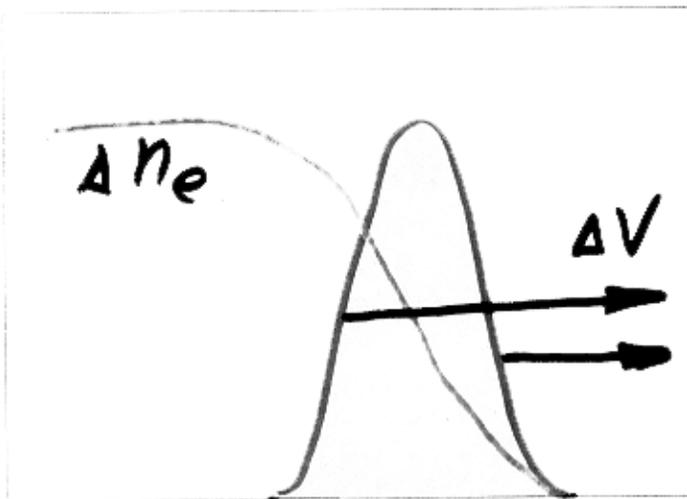
Towards Femtosecond CO₂ Laser Pulses

Gain bandwidth broadening



Pressurized mixture of CO₂ molecules composed of isotopes C¹², C¹³, C¹⁴, O¹⁶, O¹⁸ has a gain bandwidth 7 THz sufficient to amplify **100 fs** laser pulses (e.g., V. Gordienko, et. al., 1991)

Pulse chirping in ionized gas



$$\Delta V \propto \Delta n_e / n_{cr}$$

$$\text{ionization } \Delta n_e \propto \lambda^2,$$

$$n_{cr} \propto 1/\lambda^2, \text{ hence, } \Delta V \propto \lambda^4.$$

That is why self-chirping in gas is practical only with CO₂ laser.

According to P. Corkum pulse shortening from ~1 ps to ~**150 fs** is possible

High energy 10-100 J capability of CO₂ laser permits ~PW from a relatively compact amplifier.